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**Semiconductor Research Corporation Honored  
at White House Ceremony**

**- SRC wins National Medal of Technology Award -**

**San Jose, CA – July 27, 2007** – The Semiconductor Research Corporation (SRC) will be awarded the National Medal of Technology in a White House ceremony today. The SRC is a university research consortium sponsored by all segments of the semiconductor industry. SRC sponsors pre-competitive research programs on semiconductor technology at leading universities.

SIA Chairman and Texas Instruments CEO Rich Templeton said “The SRC’s collaborative research activities have played a critical role in maintaining U.S. leadership in semiconductor technology. The National Medal of Technology awarded to the SRC is a major honor and a well deserved recognition of their efforts and accomplishments.”

SIA President George Scalise said “For nearly 60 years, U.S. leadership in technology has been a major factor in driving economic growth, enhancing the productivity of American workers, improving our standard of living, advancing medicine and health care, and ensuring our national security.”

Scalise noted that SRC will celebrate its 25<sup>th</sup> anniversary later this year. “Cumulative SRC investments in university research programs are approaching a billion dollars,” he continued. “More than 5,500 students and more than 1,200 faculty members have participated in these programs. In this sense, SRC-sponsored research is a significant investment in human capital, which in the final analysis is the key to leadership in technology.”

***About the SIA***

The SIA is the leading voice for the semiconductor industry and has represented U.S. semiconductor companies since 1977. Collectively, the chip industry employs a domestic workforce of 232,000 people. More information about the SIA can be found at [www.sia-online.org](http://www.sia-online.org).